

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of: Seung Woo Shin and Cha Deok Dong) I hereby certify that this paper and the documents referred to as enclosed
Serial No.: 10/631,362	therewith are being deposited with the United States Postal Service as first class mail, postage prepaid, on March 18, 2004, in an envelope addressed to Commissioner for Patents, P.O. Box 1450 Alexandria, Virginia 22313-1450
Filed: July 31, 2003	
For: Method of Forming Oxynitride Film) Alexandra, Virginia 22313-1430
Group Art Unit: 2812) Michael R. Hull
Examiner: Alexander G. Ghyka) Reg. No. 35,902 Attorney for Applicants
)

AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Sir:

Please amend the above-identified patent application as follows:

Amendments to the specification begin on page 2 of this paper.

Amendments to the claims begin on page 7 of this paper.

Remarks/Arguments begin on page 9 of this paper.